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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyoshi Mita
Serial No. : 10/813,782
Filed : March 31, 2004
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Art Unit : 2815
Examiner : Chris C. Chu

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF NOVEMBER 29, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 28, 2006

Date of Deposit

Signature

Rose Syracuse

Typed or Printed Name of Person Signing Certificate